

Attorney Docket No.: MEMS-0160-US

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): BROWN, et al.

Conf. No.:

Application No.: 09/895,152

Art Unit: 1756

Filed: 2 Jul 2001

Examiner:
Chacko Davis, DaborahTitle: HIGH QUALITY LITHOGRAPHIC
PROCESSINGCommissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450**REPLY AND/OR AMENDMENT**

Sir:

In response to the Examiner's Advisory Action dated December 2, 2004 the following Amendments and remarks are respectfully submitted in connection with the above-identified application.

Deposit Account Authorization

Please charge any shortage in fees due in connection with the filing of this, concurrent and future replies, including extension of time fees, to Deposit Account 50-3136 and please credit any excess fees to such deposit account.

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks/Arguments begin on page 8 of this paper.